



09/413462

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PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Eduard A. Cartier, et al.

Docket: 12906

Patent No.: 6,753,556

Dated: May 26, 2005

Issued: June 22, 2004

For: SILICATE GATE DIELECTRIC

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

**Certificate
JUN 06 2005
of Correction**

REQUEST FOR CERTIFICATE OF CORRECTION

Sir:

It appears that errors have been introduced in the course of printing the Patent issued in the above application, and it is respectfully requested that the Commissioner issue a Certificate of Correction in the following respects:

**Title Page
(57)**

**References Cited
U.S. PATENT DOCUMENT are missing**

5,190,888 * 3/2/93 Schwalke et al.....
5,258,640 * 11/2/93 Hsich et al.....
5,541,131 * 7/30/96 Yoo et al.....
5,554,560 * 9/10/96 Hsue et al.....
5,672,898 * 9/30/97 Keller et al.....
5,852,318 * 12/22/98 Chikamatsu et al.....
5,876,788 * 3/2/99 Bronner et al.....

**OTHER PUBLICATIONS
(ARE MISSING)**

Hubbard, et al., "Thermodynamic Stability of Binary Oxides in Contact With Silicon," J. Mater. Res., Vol. 81 No. 11, pp. 2757-2776 (1996)

McKee, et al., "Crystalline Oxides on Silicon: The First Five Monolayers," Physical Review Letters, Vol. 81, No. 14, pp. 3014-3017 (1998)

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'L S Szivos', with a long horizontal line extending to the right.

Leslie S. Szivos

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UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO : 6,753,556 B2
APPLICATION NO : 09/413,462
ISSUE DATE : June 22, 2004
INVENTOR(S) : Eduard A. Cartier, et al.

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

(58) Title Page
References Cited
U.S. PATENT DOCUMENT are missing

5,190,888 * 3/2/93 Schwalke et al.....
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